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				Application Number	10/555,663-Conf. #9919
				Filing Date	December 4, 2006
				First Named Inventor	Shigenori FUJIKAWA
				Art Unit	4191
				Examiner Name	B. A. Schiffman
Sheet	1	of	1	Attorney Docket Number	1248-1030PUS1

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	AA*	US-20020182413-A1	12-05-2002	Kunitake et al.	
	AB*	US-5,284,707-A	02-08-1994	Ogawa et al.	
	AC*	US-5,324,566-A	06-28-1994	Ogawa et al.	
	AD*	US-5,380,585-A	01-10-1995	Ogawa et al.	
	AE*	US-5,407,709-A	04-18-1995	Ogawa et al.	
	AF*	US-5,437,894-A	08-01-1995	Ogawa et al.	
	AG*	US-5,466,486-A	11-14-1995	Ogawa et al.	
	AH*	US-5,580,605-A	12-03-1996	Ogawa et al.	
	AI*	US-20010044021-A1	11-22-2001	Ogawa et al.	
	AJ*	US-6,521,334-B1	02-18-2003	Ogawa et al.	
	AK*	US-2002/0094375-A1	07-18-2002	Ogawa et al.	
	AL*	US-2002/0127331-A1	09-12-2002	Ogawa et al.	
	AM*	US-2003/0019568-A1	01-30-2003	Liu et al.	
	AN*	US-2002/0088540-A1	07-11-2002	Chan et al.	
	AO*	US-2002/0129894-A1	09-19-2002	Liu et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
	BA	JP-10-146920-A	06-02-1998			AB
	BB	JP-2002-337100-A	11-26-2002			AB
	BC	JP-2003-124250-A	04-25-2003			AB
	BD	JP-10-249985-A	09-22-1998	Kunitake et al.		✓
Examiner Signature				Date Considered		

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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	CA	H. FUJII et al., "Synthesis of TiO <sub>2</sub> /CdS nanocomposite via TiO <sub>2</sub> coating on CdS nanoparticles by compartmentalized hydrolysis of Ti alkoxide", Journal of Materials Science, Vol. 36, pp. 527-532 (2001)	
	CB	B.E. YOLDAS, "Deposition and properties of optical oxide coatings from polymerized solutions", Applied Optics, Vol. 21, No. 16, pp. 2960-2964, August 15, 1982	

Examiner Signature		Date Considered	
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